



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Fukashi HARADA et al.**

Group Art Unit: **2811**

Serial No.: **10/649,746**

Examiner: **Ori NADAV**

Filed: **August 28, 2003**

Confirmation No.: **5719**

For: **MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE
INCLUDING AN ANISOTROPIC ETCHING STEP**

Attorney Docket Number: **031071**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

March 14, 2005

Sir:

In response to the Office Action dated October 12, 2004, the response date of which having been extended by two months to March 12, 2005, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.